

#4

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

First Named  
Inventor : Stanislav V. Aleshin et al.

Appln. No.: 09/879,664

Filed : June 12, 2001

For : MASK CORRECTION FOR  
PHOTOLITHOGRAPHIC PROCESSES

Docket No.: L13.12-0149/01-026

Group Art Unit: 2621

Examiner:

LETTER TO OFFICIAL DRAFTSPERSON

Box Issue Fee  
Commissioner for Patents  
Washington, D.C. 20231

I HEREBY CERTIFY THAT THIS PAPER IS BEING  
SENT BY U.S. MAIL, FIRST CLASS, TO THE  
ASSISTANT COMMISSIONER FOR PATENTS,  
WASHINGTON, D.C. 20231, THIS

8 DAY OF October, 20 01.

David D. Brush  
PATENT ATTORNEY

Sir:

Enclosed are **three** (3) sheets of formal drawings for  
filing in the above-identified application.

Respectfully submitted,

WESTMAN, CHAMPLIN & KELLY, P.A.

By: David D. Brush  
David D. Brush, Reg. No. 34,557  
Suite 1600 - International Centre  
900 Second Avenue South  
Minneapolis, Minnesota 55402-3319  
Phone: (612) 334-3222 Fax: (612) 334-3312

DDB:tas

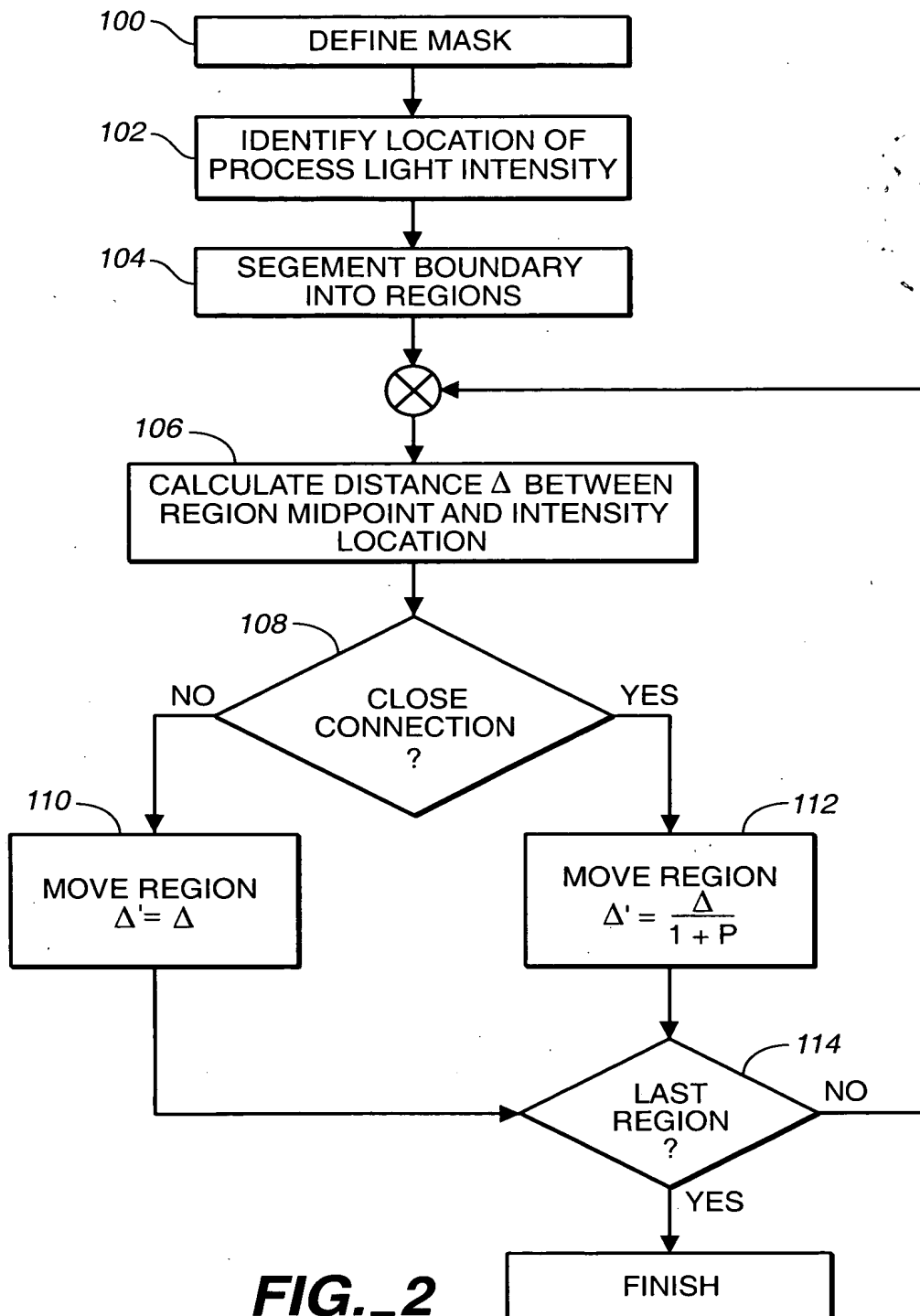
09879664-101501



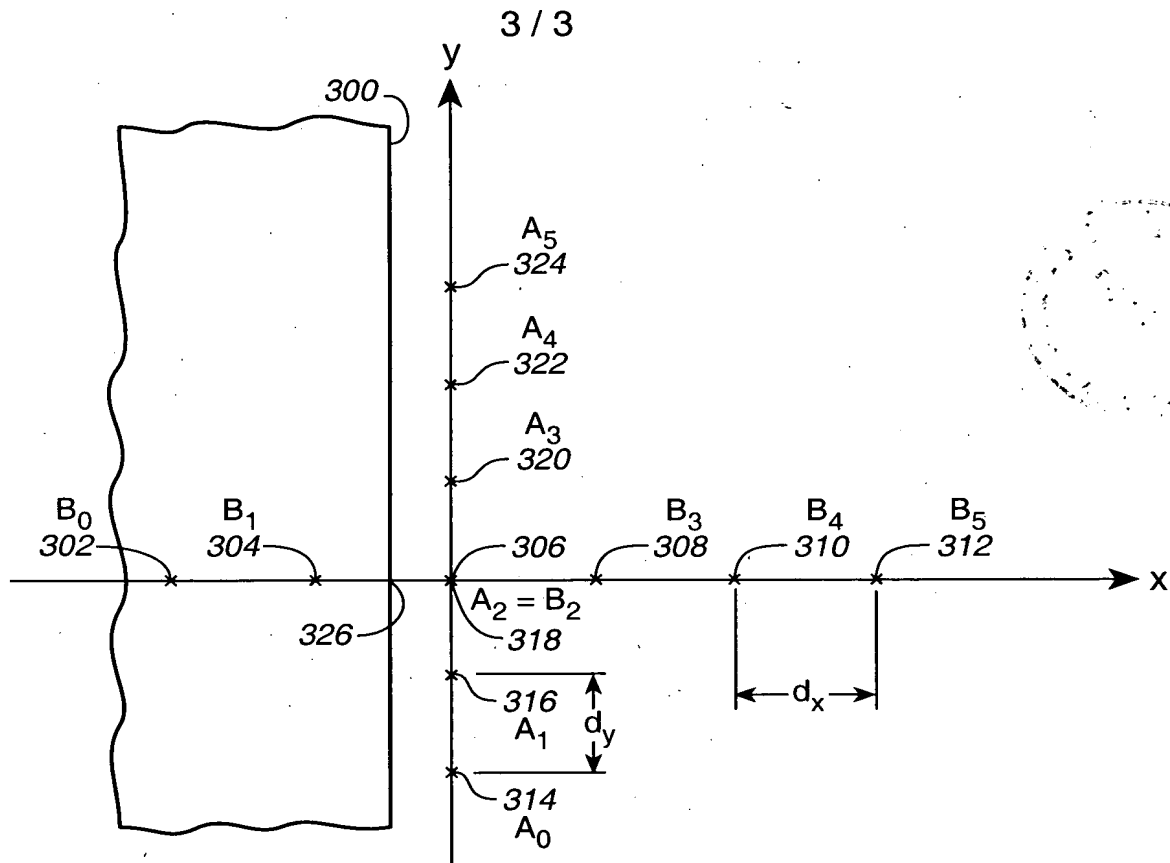
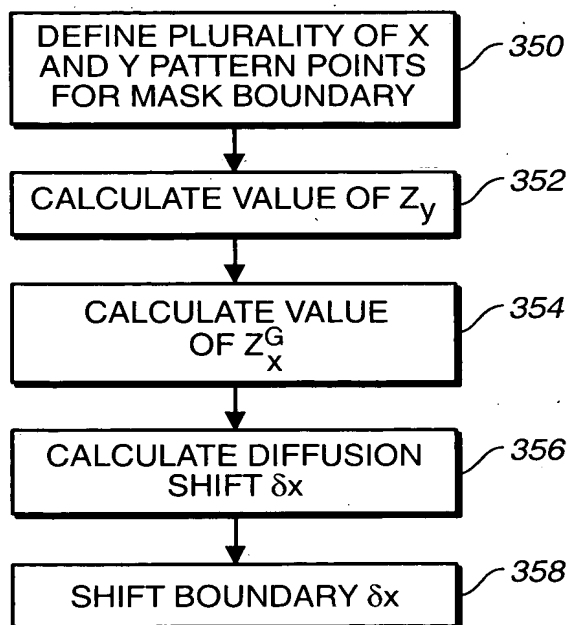
**FIG. 3**



2 / 3

**FIG.\_2**

FOOT-49962860

**FIG.\_5****FIG.\_6**

FOOT-4996/860